

Electronic Acknowledgement Receipt

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Title of Invention:	Method of patterning a metal layer in a semiconductor device
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
1		2009-02-05-IDS.pdf	860479 <div>c484bad3992167e79e1ea24ff386d95c5da bf224</div>	yes	21
	Multipart Description/PDF files in .zip description				
	Document Description		Start	End	
	Information Disclosure Statement Letter		1	5	
	Information Disclosure Statement (IDS) Filed (SB/08)		6	6	
	NPL Documents		7	8	
	Foreign Reference		9	14	
	Foreign Reference		15	21	
Warnings:					
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